

	Hit s	Search Text	DBs
51	8	((substrate or wafer) same (LCD or panel\$3 or unit or intaglio or clich\$2 or area or region or divid\$3) same pattern\$4) and (print\$4 near5 roll\$4) and (collector near5 roll) and (transfer near5 (layer or roll\$4)) and (substrate) and ((circumference or length) same (blanket or intaglio or cliche or roll\$4 or transfer))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
52	13	((substrate or wafer) same (LCD or panel\$3 or unit or intaglio or clich\$2 or area or region or divid\$3) same pattern\$4) and (print\$4 near5 roll\$4) and (collector near5 roll) and (transfer near5 (layer or roll\$4)) and ((circumference or length) same (blanket or intaglio or cliche or roll\$4 or print\$4 or transfer or layer) smae (substrate or wafer))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB

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53	8	((substrate or wafer) same (LCD or panel\$3 or unit or intaglio or clich\$2 or area or region or divid\$3) same pattern\$4) and (print\$4 near5 roll\$4) and (collector near5 roll) and (transfer near5 (layer or roll\$4)) and ((circumference or length) same (blanket or intaglio or cliche or roll\$4 or print\$4 or transfer or layer) same (substrate or wafer))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB